

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Dong et al.)	I hereby certify that this paper (or fee) is being
Serial No.: 10/722,814)	deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, MS Amendment, P.O. Box 1450, Alexandria, VA
Filed: November 26, 2003)	
For: METHOD OF FORMING GATE ELECTRODE IN SEMICONDUCTOR DEVICE	.)	22313-1450 September 8, 2006
Group Art Unit: 1765)	
Examiner: Duy Vu Nguyen Deo)) .)	James P. Zeller Reg. No. 28,491

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Commissioner for Patents MS Amendment P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend this application as follows:

the amendments to the claims section begins on page 2 of this paper;

the remarks section begins on page 5 of this paper.